

Notice of References Cited

Application/Control No.

10/564,485

Applicant(s)/Patent Under

Reexamination

CHRISSTOFFELS ET AL.

Examiner

Christopher R. Lea

Art Unit

1619

Page 1 of 1

U.S. PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A US-2001/0021375	09-2001	Hossel et al.	424/59
*	B US-2003/0147929	08-2003	Kim et al.	424/401
*	C US-2005/0265950	12-2005	Chrisstoffels et al.	424/070.17
*	D US-2005/0281774	12-2005	Muller et al.	424/070.15
*	E US-6,682,725	01-2004	Dieing et al.	424/70.11
*	F US-7,422,735	09-2008	Hossel et al.	424/70.15
G	US-			
H	US-			
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

FOREIGN PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N	WO 2001062809 A1	08-2001	World Intellect	KIM S N et al.	
O	WO 2004022616 A1	03-2004	World Intellect	CHRISSTOFFELS et al.	
P	WO 2004030642 A1	04-2004	World Intellect	MUELLER et al.	
Q					
R					
S					
T					

NON-PATENT DOCUMENTS

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
U	
V	
W	
X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a))
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.